HOW TO REACH US



FRAUNHOFER INSTITUTE FOR ELECTRONIC NANO SYSTEMS ENAS

MAY 21 AND 22, 2019 | FRAUNHOFER ENAS TECHNOLOGIE-CAMPUS 3 | 09126 CHEMNITZ

CHEMNITZER SEMINAR MEMS TECHNOLOGIES AND APPLICATIONS



Registration:

The registration is free of charge.

Please send an e-mail for registration with the information whether you would like to attend both days or only one (May 21 or 22) to chemnitzer.seminare@enas.fraunhofer.de until May 3, 2019.

Hotel:

Until April 16, rooms in Hotel Chemnitzer Hof can be ordered by using the keyword: Seminar System Packaging. single room (incl. breakfast): 69 EUR Hotel Chemnitzer Hof, Theaterplatz 4, 09111 Chemnitz phone: +49 371 684-0 | info@chemnitzer-hof.de

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PROGRAM



CHEMNITZER SEMINAR »MEMS TECHNOLOGIES AND APPLICATIONS«

Smart systems are becoming more and more important in our daily life, e.g. in cars, security applications, medical engineering, condition monitoring, logistics and other applications. A major bottleneck, however, is the integration and packaging of the sensitive microstructures on different levels to allow them to withstand even harsh environments and meet the competitive market requirements. In 2019 advanced MEMS and MEMS packaging technologies as well as current integration trends and national/international funding possibilities will be highlighted within the 32nd Chemnitzer Seminar.

TUESDAY MAY 21, 2019

12:30 – 12:40 pm	Welcome Dr. Maik Wiemer, Fraunhofer ENAS
12:40 – 1:10 pm	Keynote: Trends and Challenges in MEMS Integration Amandine Pizzagalli, Yole Développement
1:10 – 1:40 pm	MEMS based Photo-Acoustic Gas Sensor Dr. Rainer Schaller, Infineon Technologies AG
1:40 – 2:10 pm	Organic and Flexible Sensors in Applications Dr. Dominik Gronarz, Organic Electronics Saxony Management GmbH
2:10 – 2:50 pm	Poster and Demonstrator Presentation, Coffee Break and Networking
2:50 – 3:20 pm	Keynote: Quality and Reliability Testing of Wirebonds – Limitations and New Opportunities Stefan Schmitz, Bond-IQ GmbH
2:50 – 3:20 pm 3:20 – 3:50 pm	Keynote: Quality and Reliability Testingof Wirebonds – Limitations and NewOpportunities Stefan Schmitz,Bond-IQ GmbHAdvanced Surface MicromachiningProcess – a First Step towards 3D MEMS Dr. Jörg Bräuer, Robert Bosch GmbH
2:50 – 3:20 pm 3:20 – 3:50 pm 3:50 – 4:20 pm	Keynote: Quality and Reliability Testingof Wirebonds – Limitations and NewOpportunities Stefan Schmitz,Bond-IQ GmbHAdvanced Surface MicromachiningProcess – a First Step towards 3D MEMS Dr. Jörg Bräuer, Robert Bosch GmbHCapacitive Micromachined UltrasonicTransducers for Medical and Non-Medical Applications Dr. Nooshin Saeidi,Fraunhofer ENAS

WEDNESDAY MAY 22, 2019

8:30 – 8:40 am	Welcome Dr. Maik Wiemer,
	Fraunhofer ENAS
8:40 – 9:10 am	Keynote: From Sampling to Ramping
	 Technology and Business Model
	Challenges for MEMS Foundries to
	Address WLP Applications Stefan Ernst,
	X-FAB Semiconductor Foundries AG
9:10 – 9:40 am	USeP: Universal sensor platform for
	IoT applications Marco Meinig,
	Fraunhofer ENAS
9:40 – 10:10 am	Electrodeposition of Aluminum Towards
	Wafer-Level Al-Al Thermocompression
	Bonding Silvia Hertel, Fraunhofer ENAS
10:10 – 10:40 am	Poster and Demonstrator Presentation,
	Coffee Break and Networking
10:40 – 11:10 am	Current Funding Opportunities
	in Electronics and MEMS
	Dr. Gregor Schwartz, VDI/VDE
	Innovation + Technik GmbH
11:10 – 11:40 am	3D Printed Electronics for Mechatronic
	Systems Dr. Martin Hedges, Neotech
	AMT GmbH
11:40 – 12:10 pm	Building-in Reliability into Power
	Modules Dr. Jacek Rudzki, Danfoss Silicon
	Power GmbH
12:10 – 12:40 pm	Discussion and end of workshop
12:40 – 2:00 pm	Lunch
from 2:00 pm	Individual Lab and Window Tours